DOCKET NO.: 210295US99 AUG 3 0 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

GROUP ART UNIT: 2811

TOMASZ L. KLOSOWIAK ET AL

SERIAL NO.: 09/897,059

EXAMINER:

FILED: JULY 3, 2001

FOR: Structure And Method For Fabricating Semiconductor Structures And Devices Utilizing

The Formation Of A Compliant Substrate For Materials Used To Form The Same

Piezoelectric Structures Having Controllable Optical Surfaces

REQUEST FOR DEFERRAL OF EXAMINATION 37 C.F.R. §1.103(d)

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Applicants hereby request deferral of examination under 37 C.F.R. §1.103(d) for the above-identified non-reissue utility application **for a period of 36 months** from the earliest filing date for which benefit is claimed.

The Director is authorized to charge the following fees, or credit any overpayment, to Deposit Account No. 15-0030:

Processing fee as set forth in 37 C.F.R. §1.17(i) for request for deferral of examination;

Publication fee set forth in 37 C.F.R. §1.18(d).

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

09/23/2002 CHCKINNE 00000001 150030 09897059

01 FC:122 02 FC:195

130.00 CH 300.00 CH

Richard L. Treanor Attorney of Record

Registration No.: 36,379

22850

Telephone: (703) 413-3000 Facsimile (703) 413-2220



Docket No.: 210295US99

OBLON SPIVAK **McClelland** MAIER NEUSTADT P.C.

ATTORNEYS AT LAW

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

> RE: Application Serial No.: 09/897.059

> > Applicants: Tomasz L. KLOSOWIAK, et al.

Filing Date: July 3, 2001

For: STRUCTURE AND METHOD FOR FABRICATING

SEMICONDUCTOR STRUCTURES AND

DEVICES UTILIZING THE FORMATION OF A COMPLIANT SUBSTRATE FOR MATERIALS

USED TO FORM THE SAME AND

PIEZOELECTRIC STRUCTURES HAVING CONTROLLABLE OPTICAL SURFACES

Group Art Unit: 2811

Examiner:

SIR:

Attached hereto for filing are the following papers:

Request for Deferral of Examination 37 C.F.R. 1.103(d)

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Richard L. Treanor Attorney of Record Registration No. 36,379



1755 JEFFERSON DAVIS HIGHWAY FOURTH FLOOR ARLINGTON, VIRGINIA 22202 IU.S.A. TELEPHONE: 703-413-3000 ■ FACSIMILE: 703-413-2220 ■ www.oblon.com